



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Choi et al. PATENT APPLICATION  
Serial No: 10/616,799 Group Art Unit: Unassigned  
Filed: July 10, 2003 Examiner: Unassigned  
For: A method of manufacturing a vacuum chuck used in  
imprint lithography

SUPPLEMENTAL PRELIMINARY AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This amendment is filed in conjunction with  
preliminary amendment filed July 10, 2003.

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